

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	4563367.pn. and (fluorine or fluoride)	1	<u>1.15</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	L12 and (clean\$3 with window)	97	<u>1.14</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	L12 and (window)	1027	<u>1.13</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	L11 and (fluoride or tri-fluoride or trifluoride or fluorine) and gas\$3	3558	<u>1.12</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	((clean\$3 or etch\$3 or remov\$4) with (chamber or wall\$1 or reactor)) and (plasma or PECVD) and (opening\$1 or hole\$1 or orifice\$1 or head or showerhead)	15836	<u>1.11</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	(clean\$3 near3 chamber) and PECVD and (opening\$1 or hole\$1 or orifice\$1 or head or showerhead)	276	<u>1.10</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	((nitrogen adj fluoride) or NF3) and CVD and electrode\$1	144	<u>1.9</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	(nitrogen adj fluoride) and CVD and electrode\$1	83	<u>1.8</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	(PHCVD or (photon-induced adj CVD) or (photo adj CVD)) and (PECVD or plasma) and (SiN or nitride)	288	<u>1.7</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	15 AND fluoride	2	<u>1.6</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	4529474.PN.	3	<u>1.5</u>
USPT.PGPB.JPAB.EPAB.DWPL.TDBD	CLEAN\$3 WITH (nf3 OR (NITROGEN ADJ (FLUORIDE OR FLOURIDE)))	178	<u>1.4</u>
PGPB.JPAB.EPAB.DWPL.TDBD	(PHCVD or (photon-induced adj CVD) or (photo adj CVD)) and (SiN or (Silicon adj nitride)) and oxide\$1	19	<u>1.3</u>
USPT	(hyper and light).ti.	1	<u>1.2</u>
USPT	(PHCVD or (photon-induced adj CVD) or (photo adj CVD)) and (SiN or (Silicon adj nitride)) and oxide\$1	211	<u>1.1</u>